

| L Number | Hits | Search Text | DB | Time stamp |
|----------|------|--|---|------------------|
| 1 | 783 | {430/312}.CCLS. | USPAT | 2004/03/13 19:18 |
| 2 | 11 | ("6153978" "6137213" "6137272" "6096570" "6008576" "5877594" "5557596" "5541473" "5528103" "5090932" "4923421").PN. | USPAT; US-PGPUB; EPO; JPO; IBM_TDB | 2004/03/13 19:24 |
| 3 | 0 | ((("6153978" "6137213" "6137272" "6096570" "6008576" "5877594" "5557596" "5541473" "5528103" "5090932" "4923421").PN.) and (undercut\$5 under adj cut\$5) | USPAT; US-PGPUB; EPO; JPO; IBM_TDB | 2004/03/13 19:25 |
| 4 | 8 | ((("6153978" "6137213" "6137272" "6096570" "6008576" "5877594" "5557596" "5541473" "5528103" "5090932" "4923421").PN.) and (radius diameter) | USPAT; US-PGPUB; EPO; JPO; IBM_TDB | 2004/03/13 19:25 |
| 5 | 25 | (field adj emission fed).ab,ti,clm. and overhang with gate | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2004/03/13 19:51 |
| 6 | 1 | (field adj emission fed).ab,ti,clm. and overhang\$4 with (micron mil ".mu.m" micrometer micrometre micro adj (meter metre) nanometer nm \$6".angstrom.") same gate | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2004/03/13 20:07 |
| 7 | 1 | 5232549.pn. | USPAT; US-PGPUB; EPO; JPO; IBM_TDB | 2004/03/13 20:07 |
| - | 2 | 20020190623.did. | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2004/03/12 11:09 |
| - | 1 | 20020190623.did. | USPAT; US-PGPUB; EPO; JPO; IBM_TDB | 2004/03/12 12:22 |
| - | 2 | 5413513.pn. 5658832.pn. | USPAT; US-PGPUB; EPO; JPO; IBM_TDB | 2004/03/12 11:23 |
| - | 1 | 20020190623.did. and (ratio etching microns) | USPAT; US-PGPUB; EPO; JPO; IBM_TDB | 2004/03/12 13:19 |
| - | 4198 | ((445/24,25) or (427/77,105,106,133) or (437/228) or (430/325)).CCLS. | USPAT | 2004/03/12 13:46 |
| - | 523 | ((445/24,25) or (427/77,105,106,133) or (437/228) or (430/325)).CCLS. | US-PGPUB | 2004/03/12 13:40 |
| - | 5706 | ((445/24,25) or (427/77,105,106,133) or (437/228) or (430/325)).CCLS. | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2004/03/12 13:48 |
| - | 38 | ((445/24,25) or (427/77,105,106,133) or (437/228) or (430/325)).CCLS.) and etch\$6 with (undercut under adj cut) and polymer | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2004/03/12 14:06 |
| - | 5706 | ((445/24,25) or (427/77,105,106,133) or (437/228) or (430/325)).CCLS. | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2004/03/12 13:48 |
| - | 38 | ((445/24,25) or (427/77,105,106,133) or (437/228) or (430/325)).CCLS.) and etch\$6 with (undercut under adj cut) and polymer | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2004/03/12 13:48 |

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|---|------|--|---|------------------|
| - | 38 | ((((445/24,25) or (427/77,105,106,133) or (437/228) or (430/325)).CCLS.) and etch\$6 with (undercut under adj cut) and polymer) and etch\$6 with (undercut under adj cut) | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2004/03/12 13:58 |
| - | 5 | ((((445/24,25) or (427/77,105,106,133) or (437/228) or (430/325)).CCLS.) and etch\$6 with (undercut under adj cut) and polymer) and etch\$6 with (undercut under adj cut) and (tunnel\$6) | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2004/03/12 13:58 |
| - | 15 | ((((445/24,25) or (427/77,105,106,133) or (437/228) or (430/325)).CCLS.) and etch\$6 with (undercut under adj cut) same (micron ratio ".mu.m" micrometer micrometre nanometer nanometre) | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2004/03/12 14:16 |
| - | 2 | ((((445/24,25) or (427/77,105,106,133) or (437/228) or (430/325)).CCLS.) and etch\$6 with (undercut under adj cut) same (micron ratio ".mu.m" micrometer micrometre nanometer nanometre) and tunnel\$6 | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2004/03/12 14:50 |
| - | 1 | 20020190623.did. and tunneling adj layer | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2004/03/12 14:23 |
| - | 0 | ((((445/24,25) or (427/77,105,106,133) or (437/228) or (430/325)).CCLS.) and etch\$6 adj profile with (undercut under adj cut) | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2004/03/12 14:51 |
| - | 2529 | (313/495-497,310).CCLS. | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2004/03/12 15:30 |
| - | 66 | ((313/495-497,310).CCLS.) and (undercut under adj cut) | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2004/03/12 17:40 |
| - | 12 | ((313/495-497,310).CCLS.) and (ledge) not (((313/495-497,310).CCLS.) and (undercut under adj cut)) | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2004/03/12 16:12 |
| - | 2037 | (430/313,316,317.318).CCLS. | USPAT; US-PGPUB | 2004/03/12 16:12 |
| - | 194 | ((430/313,316,317.318).CCLS.) and (undercut ledge under adj cut) | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2004/03/12 16:14 |
| - | 229 | ((430/313,316,317.318).CCLS.) and (undercut\$5 ledge under adj cut\$6) same etch\$8 | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2004/03/12 16:18 |
| - | 63 | ((430/313,316,317.318).CCLS.) and (undercut\$5 ledge under adj cut\$6) same etch\$8 same (micron ".mu.m" "mu.m" "mu.m." micrometer micro adj (meter metre) micrometre nanometer nm "angstrom") | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2004/03/12 17:24 |
| - | 1 | 20020190623.did. | USPAT; US-PGPUB; EPO; JPO; IBM_TDB | 2004/03/12 17:25 |
| - | 1 | 20020190623.did. and undercut | USPAT; US-PGPUB; EPO; JPO; IBM_TDB | 2004/03/12 17:25 |

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|---|----|--|---|------------------|
| - | 11 | ((313/495-497,310).CCLS.) and (undercut\$4 under adj cut\$5) not (((313/495-497,310).CCLS.) and (undercut under adj cut)) not (((313/495-497,310).CCLS.) and (ledge) not (((313/495-497,310).CCLS.) and (undercut under adj cut))) | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2004/03/12 18:50 |
| - | 8 | (field adj emission fed).ab,ti,clm. and undercut\$5 with aspect adj ratio | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2004/03/13 19:42 |

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| 3 | 0 | ((("6153978" "6137213" "6137272" "6096570" "6008576" "5877594" "5557596" "5541473" "5528103" "5090932" "4923421").PN.) and (undercut\$5 under adj cut\$5) | USPAT; US-PGPUB; EPO; JPO; IBM_TDB | 2004/03/13 19:25 |
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| 6 | 1 | (field adj emission fed).ab,ti,clm. and overhang\$4 with (micron mil ".mu.m" micrometer micrometre micro adj (meter metre) nanometer nm \$6".angstrom.") same gate | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2004/03/13 20:07 |
| 7 | 1 | 5232549.pn. | USPAT; US-PGPUB; EPO; JPO; IBM_TDB | 2004/03/13 20:07 |
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| - | 1 | 20020190623.did. | USPAT; US-PGPUB; EPO; JPO; IBM_TDB | 2004/03/12 12:22 |
| - | 2 | 5413513.pn. 5658832.pn. | USPAT; US-PGPUB; EPO; JPO; IBM_TDB | 2004/03/12 11:23 |
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| - | 523 | ((445/24,25) or (427/77,105,106,133) or (437/228) or (430/325)).CCLS. | US-PGPUB | 2004/03/12 13:40 |
| - | 5706 | ((445/24,25) or (427/77,105,106,133) or (437/228) or (430/325)).CCLS. | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2004/03/12 13:48 |
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| - | 5706 | ((445/24,25) or (427/77,105,106,133) or (437/228) or (430/325)).CCLS. | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2004/03/12 13:48 |
| - | 38 | ((445/24,25) or (427/77,105,106,133) or (437/228) or (430/325)).CCLS.) and etch\$6 with (undercut under adj cut) and polymer | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2004/03/12 13:48 |

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| - | 38 | ((((445/24,25) or (427/77,105,106,133) or (437/228) or (430/325)).CCLS.) and etch\$6 with (undercut under adj cut) and polymer) and etch\$6 with (undercut under adj cut) | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2004/03/12 13:58 |
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| - | 2 | ((((445/24,25) or (427/77,105,106,133) or (437/228) or (430/325)).CCLS.) and etch\$6 with (undercut under adj cut) same (micron ratio ".mu.m" micrometer micrometre nanometer nanometre) and tunnel\$6 | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2004/03/12 14:50 |
| - | 1 | 20020190623.did. and tunneling adj layer | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2004/03/12 14:23 |
| - | 0 | ((((445/24,25) or (427/77,105,106,133) or (437/228) or (430/325)).CCLS.) and etch\$6 adj profile with (undercut under adj cut) | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2004/03/12 14:51 |
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| - | 194 | ((430/313,316,317.318).CCLS.) and (undercut ledge under adj cut) | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2004/03/12 16:14 |
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| - | 1 | 20020190623.did. | USPAT; US-PGPUB; EPO; JPO; IBM_TDB | 2004/03/12 17:25 |
| - | 1 | 20020190623.did. and undercut | USPAT; US-PGPUB; EPO; JPO; IBM_TDB | 2004/03/12 17:25 |

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